

AMENDMENT UNDER 37 C.F.R. § 1.116 EXPEDITING PROCEDURE EXAMINING GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Luetzen, et al.

Docket No.:

Serial No.:

10/721,225

Art Unit:

1763

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Filed:

November 26, 2003

Examiner:

George A. Goudreau

For:

Method and Structures for Increasing the Structure Density and the Storage

Capacitance in a Semiconductor Wafer

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated October 31, 2006, which Action is made final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of claims 1-13 and 21-27.